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Bib Data Sheet

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SERIAL NUMBER 10/645,780	FILING DATE 08/22/2003  RULE	CLASS 359	GROUP ART UNIT 2873	ATTORNEY DOCKET NO. 105198.04
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APPLICANTS

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**\*\* CONTINUING DATA \*\*\*\*\***

This application is a DIV of 10/310,780 12/06/2002 PAT 6,639,732  
which is a DIV of 10/060,316 02/01/2002 PAT 6,512,641  
which is a DIV of 09/721,956 11/27/2000 PAT 6,362,926  
which is a DIV of 09/328,198 06/08/1999 PAT 6,195,213

**\*\* FOREIGN APPLICATIONS \*\*\*\*\***

JAPAN 10-159102 06/08/1998  
JAPAN 10-181497 06/12/1998  
JAPAN 10-186833 06/17/1998  
JAPAN 10-309677 10/30/1998  
JAPAN 10-366265 12/24/1998

IF REQUIRED, FOREIGN FILING LICENSE GRANTED  
**\*\* 01/05/2004**

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 19	TOTAL CLAIMS 9	INDEPENDENT CLAIMS 1
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature	Initials		

ADDRESS  
25944  
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TITLE  
Projection exposure apparatus and method